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IN THE ABSTRACT:

Please amend the abstract of the disclosure as follows (bracketed portions are removed, and underlined portions are inserted):

A field distribution measuring method for measuring a spatial distribution of an electric field or a magnetic [fields] field at a plurality of sampling points [by the probe]. The method includes the steps of continuously sweeping the sampling points by a probe, in which, based on spurious spectra generated by offsets between positions of the probe and measuring timings, a shift amount of the sampling points is computed, and, taking into account the shift amount, a distribution of electric fields or magnetic fields is measured. [Thus,] The method further includes a step of removing the measured noises generated due to the offsets between sweeping positions of the probe and the measuring timings [can be properly removed].